



PATENT APPLICATION

REC'D  
SFA

UNITED STATES PATENT AND TRADEMARK OFFICE

Date May 12, 2006

In re the Application of

Masahiro YOSHIKAWA

Group Art Unit: 2828

Application No.: 10/629,777

Examiner: T. VAN ROY

Filed: July 30, 2003

Docket No.: 116722

For: SURFACE EMITTING SEMICONDUCTOR LASER (AS PREVIOUSLY AMENDED)

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 18, 2006, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 179781 in the amount of \$120 in payment for:

- X Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
       Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
       Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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05/15/2006 SZEWDIE1 00000050 10629777

JAO:KXH/tbh

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DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461